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Applicant: Mashiro Sasaura et al.
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 For: METHOD AND APPARATUS FOR PREPARING CRYSTAL

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 Att'y Docket No.: 14321.82
 Art Unit: 1722

INFORMATION DISCLOSURE CITATIONS MADE BY APPLICANTU.S. Patent Documents

<u>Examiner Initial*</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>
____ 1	4,404,172	09/13/1983	Gault
____ 2	4,521,272	06/04/1985	Gault
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Foreign Patent Documents

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____ 9	61-236681	10/21/1986	Japan	Yes
____ 10	62-096387	05/02/1987	Japan	No
____ 11	62-59593	03/16/1987	Japan	Yes
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____ 13	11/1388	06/01/1999	Japan	Yes
____ 14	WO99/63132	09/12/1999	PCT	No

Other Documents
(including author, title, pertinent pages, etc.)

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Examiner: /Felisa Hiteshew/ Date Considered: 09/03/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /F.H./